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Sheet 1 of, 1

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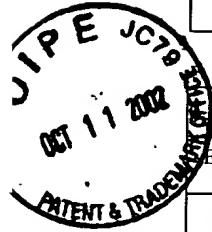
Form 1449*		Docket Number: G&C 122.6-US-U1	Application Number: 09/895,303
INFORMATION DISCLOSURE STATEMENT		Applicant: Paul F. Crowder et al.	
IN AN APPLICATION		Filing Date: June 29, 2001	Group Art Unit: 2881

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,622,672	11/11/86	Coldren			
	4,896,325	01/23/90	Coldren			
FOREIGN PATENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	EP 0 774 684 A2	05/21/97	Europe			<input checked="" type="checkbox"/>
	EP 0 926 789 A2	06/30/99	Europe			<input checked="" type="checkbox"/>
	WO 99/40654	08/12/99	PCT			<input checked="" type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Ishii, Hiroyuki et al., "Mode Stabilization Method for Superstructure-Grating DBR Lasers", Journal of Lightwave Technology, IEEE, Vol. 16, No. 3, March 1, 1998, pp. 433-442, XP000751395.				
		Sarlet, G. et al., "Wavelength and Mode Stabilization of Widely Tunable SG-DBR and SSG-DBR Lasers", IEEE Photonics Technology Letters, IEEE, Vol. 11, No. 11, November 1999, pp. 1351-1353, XP000893767.				

EXAMINER: <i>Jeffrey T. Zahn</i>	DATE CONSIDERED: <i>3/16/03</i>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	

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U.S. PATENT DOCUMENTS

FOREIGN PATENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER: <u>Jacqueline Zahn</u>	DATE CONSIDERED: <u>3/10/2007</u>
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